Electronic Filing System (EFS) Data Electronic Patent Application Submission USPTO Use Only

EFS ID:

65350

Application ID:

10710653

Title of Invention:

PRESSURE ASSISTED WAFER HOLDING APPARATUS AND

CONTROL METHOD

First Named Inventor:

David Bain

Domestic/Foreign Application:

Domestic Application

Filing Date:

2004-07-27

Effective Receipt Date:

2004-07-27

Submission Type:

Utility Patent Filing

Filing Type:

new-utility

Confirmation number:

4652

Attorney Docket Number:

FIS920040119US1

Total Fees Authorized:

810.0

Payment Category:

Deposit Account

Deposit Account Number:

90458

Deposit Account Name:

James J. Cioffi

RAM Payment Status:

RAM has not been processed

Digital Certificate Holder: cn=James J. Cioffi,ou=Registered Attorneys,ou=Patent and Trademark

Office,ou=Department of Commerce,o=U.S. Government,c=US

Certificate Message Digest: c92ca52181ef726718b2b37164adeb7942cf11f5

•

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE FEE RECORD SHEET

07/28/2004 HDEMESS1 00000054 090458 10710653

01 FC:1001

770.00 DA

PTO-1556 (5/87)